

OPTIMIZED CONTACT DESIGN FOR THERMOSONIC BONDING OF FLIP-CHIP DEVICES

BACKGROUND

[0001] The present inventive subject matter relates to the electronic arts. It finds particular application in conjunction with group III-V flip-chip bonded light emitting diodes (LEDs) for lighting applications, and will be described with particular reference thereto. However, one of ordinary skill in the art will appreciate that it is also amenable to other like applications, e.g., in conjunction with, other types of flip-chip LEDs, other flip-chip bonded epitaxial semiconductor devices (such as vertical cavity surface emitting laser diodes), other non-flip-chip bonding arrangements, etc.

[0002] Traditionally, LEDs have been packaged with a die or chip having its substrate down on a heat sink; here, light is extracted from the LED through current spreading, semi-transparent layers deposited on, for example, the die or chip's p-type layer. However, the overall light extraction efficiency of the device can be hindered due to light absorption in the current spreading layer. An alternative method to the aforementioned packaging is to use a flip-chip geometry in which light extraction is primarily through the substrate. For example, it has been shown that a 60% increase in light extraction efficiency can be obtained by flip-chip mounting.

[0003] The manufacture of a high lumen output LED can benefit from flip-chip packaging or mounting. In the flip-chip mounting configuration, an LED die (typically, with a light-transmissive substrate arranged on a back side and p and n-electrodes arranged on a front side opposite the back side) is bonded "face down" to a mount or sub-mount, i.e., with the epitaxial layers proximate to the mount and the substrate distal from the mount. The flip-chip arrangement has a number of advantages, e.g., including improved thermal heat sinking due to the proximity of the active layers to the heat sink, and reduction of electrode shadowing losses.

[0004] In flip-chip mounting configurations, solder bumps (e.g., greater than approximately 50 μm) are typically used to attach the die or chip to its mount or sub-mount (see, e.g., FIGURE 1). FIGURE 1 shows an LED including a die or chip **10** attached or being attached to a support **20** via solder bumps **30**. The die **10** has an epitaxial structure **12**, typically including multiple layers of semiconductor material

and forming an active light-generating region **14** (e.g., a double heterostructure, multiple quantum well (MQW), or other suitable light-generating configuration), that is usually disposed on a substrate **16** that is substantially transparent or transmissive to light at the wavelength generated. A pair of electrodes and/or electrical contacts (e.g., a p-type contact **18p** and an n-type contact **18n**) are also arranged on the LED in operative electrical communication with the light-generating region **14** so that electrical power supplied to the LED therethrough drives the same to generate light. In a so called lateral current flip-chip LED device, the electrodes are commonly located on the same side of the epitaxial structure **12** generally opposite the substrate **16**, as opposed to a so called vertical current LED device where the pair of electrodes are usually arranged on two sides of the LED, each on a side opposite from the other.

[0005] In operation, an electric current passed through the LED, using the electrical contacts, is carried principally by electrons in an n-type layer **12n** and by electron vacancies or "holes" in a p-type layer **12p**. The electrons and holes move in opposite directions toward the active region **14** or a junction, where they recombine with one another. Energy released by the electron-hole recombination is emitted from the LED as light. As used herein, the term "light" includes visible light as well as electromagnetic radiation in the infrared and ultraviolet wavelength ranges. The wavelength of the emitted light depends upon many factors, including the composition of the semiconductor materials, the structure of the junction, the presence or absence of impurities or doping, and the like.

[0006] Commonly, the LED is mounted to the support **20** (e.g., a sub-mount, printed circuit board (PCB), reflector cup, etc.) in flipped orientation, that is, with the light-generating region **14** proximate to the support **20** and the substrate **16** distal from the support **20**. In the flip chip arrangement, the goal is generally to extract a substantial amount of light from the LED through the light-transmissive substrate **16**.

[0007] FIGURE 2 shows a typical contact layout or contact trace for flip-chip bonding. Bump areas are designated for each electrode or contact type. For example, n-type bump areas **32n** are designated on the n-type contact **18n**, and p-type bump areas **32p** are designated on the p-type contact **18p**. The respective bump areas correspond to the locations, within the respective p and n-type contact

layouts or traces, where the solder bumps **30** contact and/or bond with the respective p and n-type electrodes or contacts **18p** and **18n**.

[0008] For flip-chip packaging of LEDs, solder attachment has its own merits and drawbacks. One advantage is that the relatively large thickness of the solder tends to planarize; thus, limiting restrictions that are placed on the difference in thickness between, or the relative elevation/height of, the p and n-type contacts **18p** and **18n**. Note, e.g., the different elevations of the p and n-type contacts **18p** and **18n** in FIGURE 1. Solder attachment of the chip **10** to the support **20**, however, can suffer from high thermal resistance; in addition, since it is often the first step of a packaging process, a high re-flow temperature can be demanded (e.g., greater than approximately 250° C) and this may compromise the reflectivity of the p-type contact **18p**, which is otherwise desirable. Also, solder processes typically require cleaning of flux residue after bonding. The cleaning solution or residual flux may compromise the LED's reliability by creating a leakage path through resistive shunt.

[0009] In a flip-chip LED configuration, desirable characteristics for die attachment include low thermal resistivity and structural robustness. Both of these can be fulfilled by using thermosonic (TS) bonding for packaging or mounting. However, the TS bonding process can present its own challenges, e.g., maintaining good contact across the chip area.

[0010] With reference to FIGURE 3, TS bonding typically employs Au bumps **34** arranged on the support **20** that enable the chip or die **10** (via the p and n-type contacts **18p** and **18n** which are also typically terminated with Au) to be attached or bonded to the support **20** with the application of ultrasonic energy, and without any intermediate melting/re-solidification step. Consequently, lower packaging temperatures (e.g., around approximately 150° C) can be used, thus avoiding loss of reflectivity of the p-type contact **18p**. In addition, the use of Au bumps **34** instead of solder, lowers the thermal resistance of the package.

[0011] Commonly, deformation of the Au bumps **34**, and physical bonding of the Au bumps **34** to the respective p and n-type bump areas **32p** and **32n** designated on the chip **10**, occurs in TS bonding. Accordingly, it is advantageous to have the p and n-type bump areas **32p** and **32n** on the chip **10** at more or less the same elevation, i.e., within the extent of deformation of the Au bumps **34**. The tendency is therefore

to manufacture an LED die for use in a TS bonding application with a thickened or elevated n-type contact **18n**. Note, e.g., the substantially similar elevations of the p and n-type contacts **18p** and **18n** in FIGURE 3, and compare the thickness or elevation of the n-type contact **18n** in FIGURE 3 with that of FIGURE 1.

[0012] In a typical chip **10**, a significant amount of the light may be emitted from a outer periphery of the active region **14**. However, as can be appreciated, with a contact layout or trace such as that illustrated in FIGURE 2 and contact elevations such as those illustrated in FIGURE 3, the n-type contact **18n** completely encircles the outer periphery of the active region **14**. Consequently, light emitted therefrom may be blocked from exiting the die **10**, e.g., getting absorbed, or otherwise trapped in the die **10**, by the n-type contact layout or trace on the chip **10**. This can result in a significant loss of light extraction efficiency.

[0013] At first glance, it might appear from FIGURES 1 through 3, that the easiest way to minimize the aforementioned light extraction issue is to eliminate that portion of the n-type contact layout or trace not containing any n-type bump areas **32n**, e.g., having a contact layout or trace as shown in FIGURE 4, where the n-type contact **18n** is restricted to one edge of the die **10**, or so that the n-type trace does not encircle the entire outer periphery. However, this can lead to poor current spreading and non-uniform light emission. For example, most of the light would tend to be emitted from that portion of the active region **14** where the p-type layer **12p** is proximate to the n-type trace or contact **18n**, which would in turn still hinder its extraction.

[0014] In some designs, the n-type trace can include several electrically separated regions or pieces, interconnected only on the mount or sub-mount level. However, if the chip or mount or sub-mount planarity is imperfect, one of such pieces may not be firmly connected to the bumps, resulting in higher electrical resistance of that piece and current spreading non-uniformity.

[0015] Accordingly, a new and improved LED and/or semiconductor die and/or method for packaging and/or mounting the same is disclosed that overcomes the above-referenced problems and others.

BRIEF DESCRIPTION

[0016] In accordance with one exemplary embodiment, a light emitting device including a semiconductor die is provided. The semiconductor die includes: an epitaxial structure arranged on a substrate, the epitaxial structure forming an active light generating region between a first layer on a first side of the active region and having a first conductivity type, and a second layer on a second side of the active region and having a second conductivity type, the second side of the active region being opposite the first side of the active region and the second conductivity type being different than the first conductivity type; a first contact in operative electrical communication with the active region via the first layer in the epitaxial structure, the first contact being arranged on a side of the epitaxial structure opposite the substrate; a second contact in operative electrical communication with the active region via the second layer in the epitaxial structure, the second contact being arranged on a side of the epitaxial structure opposite the substrate; a first contact trace corresponding to the first contact and defined at a surface thereof distal from the substrate, the first trace including at least one area designated for bonding; and, a second contact trace corresponding to the second contact and defined at a surface thereof distal from the substrate, the second trace including at least one area designated for bonding. Suitably, the first contact trace is substantially enclosed within the second contact trace.

[0017] In accordance with another exemplary embodiment, a method of manufacturing a light emitting device is provided. The method includes: providing a semiconductor die, the semiconductor die including an epitaxial structure arranged on a substrate, the epitaxial structure having an active light generating region between a first layer on a first side of the active region and having a first conductivity type, and a second layer on a second side of the active region and having a second conductivity type, the second side of the active region being opposite the first side of the active region and the second conductivity type being different than the first conductivity type; forming a first contact on the semiconductor die in operative electrical communication with the active region via the first layer of the epitaxial structure, the first contact being arranged on a side of the epitaxial structure opposite the substrate and having a corresponding first contact trace defined at a surface

thereof distal from the substrate, the first trace including at least one area designated for bonding; and, forming a second contact on the semiconductor die in operative electrical communication with the active region via the second layer of the epitaxial structure, the second contact being arranged on a side of the epitaxial structure opposite the substrate and having a corresponding second contact trace defined at a surface thereof distal from the substrate, the second trace including at least one area designated for bonding. Suitably, the first contact trace is substantially enclosed within the second contact trace.

[0018] Numerous advantages and benefits of the inventive subject matter disclosed herein will become apparent to those of ordinary skill in the art upon reading and understanding the present specification.

BRIEF DESCRIPTION OF THE DRAWINGS

[0019] The present inventive subject matter may take form in various components and arrangements of components, and in various process operations or method steps and arrangements of process operations or method steps. The drawings are only for purposes of illustrating preferred embodiments and are not to be construed as limiting. In various views, it may be advantageous to show exaggerated layer thicknesses and/or illustrate other dimensions out of portion to one another for visual clarity of selected elements or other reasons. The figures are therefore not drawn to scale.

[0020] FIGURE 1 is a diagrammatic illustration showing a cross-sectional view of a typical LED die or chip that is flip-chip mounted to a support in accordance with a conventional soldering process.

[0021] FIGURE 2 is a diagrammatic illustration showing a top plan view of an exemplary LED die or chip having a contact layout or contact traces traditionally used in connection with a flip-chip mounting configuration.

[0022] FIGURE 3 is a diagrammatic illustration showing a cross-sectional view of a typical LED die or chip that is flip-chip mounted to a support in accordance with a conventional TS bonding process.

[0023] FIGURE 4 is a diagrammatic illustration showing a top plan view of an exemplary LED die or chip having an alternate contact layout or contact traces for use in connection with a flip-chip mounting configuration.

[0024] FIGURE 5, depicting aspects of the present inventive subject matter, is a diagrammatic illustration showing a cross-sectional view of an exemplary LED die or chip that is flip-chip mounted to a support.

[0025] FIGURE 6 is a diagrammatic illustration showing a top plan view of an exemplary LED die or chip having a contact layout or contact traces embodying aspects of the present inventive subject matter.

[0026] FIGURE 7 is a diagrammatic illustration showing a top plan view of an exemplary LED die or chip having an alternate contact layout or contact traces embodying aspects of the present inventive subject matter.

[0027] FIGURE 8 is a diagrammatic illustration showing a top plan view of an exemplary LED die or chip having yet another alternate contact layout or contact traces embodying aspects of the present inventive subject matter.

DETAILED DESCRIPTION OF PREFERRED EMBODIMENT(S)

[0028] With reference to FIGURE 1, there is shown an LED **A**, including an exemplary die or chip **100** mounted or being mounted to a support **200** (e.g., a mount, a sub-mount, a printed circuit board (PCB), a reflector cup, etc.) via a plurality of bonding bumps **300**. While the LED **A** is illustrated for exemplary purposes herein, it is to be appreciated that device may be another suitable and/or similar light emitting device, or other suitable and/or similar semiconductor device.

[0029] For the illustrated LED **A**, the die **100** has an epitaxial structure **120** including multiple layers of semiconductor material and forming an active light-generating region **14** (e.g., a double heterostructure, multiple quantum well (MQW), or other suitable light-generating configuration). The structure **120** is disposed on a substrate **160**. Suitably, the substrate **160** is substantially transparent or transmissive to light, e.g., at one or more wavelengths generated by the LED **A**. While only the illustrated epitaxial layers have been shown for purposes of the present example, it is to be appreciated that one or more additional and/or alternate structures or layers

appropriate to a particular device may also be included, e.g., forming cladding layers, diffusion layers, refractive index matching layers, buffer layers, reflective layers, etc.

[0030] Suitably, the LED **A** is a group III-V based semiconductor device, e.g., an GaN and/or InGaN based device. However, the LED **A** is optionally based on an alternate system or configuration. The LED **A** suitably emits a spectrum of light in the ultraviolet and/or blue wavelength ranges, but may emit light having one or more wavelengths suitably ranging from infrared to ultraviolet. Suitably, the substrate **160** is sapphire, but may be any other appropriate material for the particular device, e.g., SiC, GaN, etc.

[0031] A pair of electrodes and/or electrical contacts (e.g., n-type contact **180n** and p-type contact **180p**) are also arranged on the LED in operative electrical communication with the light-generating region **140**, e.g., via n-type and p-type layers of the epitaxial structure **120**, i.e., layers **120n** and **120p** respectively. Accordingly, electrical power supplied to the LED **A** through the electrodes **180n** and **180p** drives the same to generate light. As illustrated, the LED **A** is a lateral current flip-chip LED device, with the electrodes **180n** and **180p** commonly located on the same side of the epitaxial structure **120**, generally opposite the substrate **160**.

[0032] In operation, an electric current passed through the LED **A**, using the electrical contacts **180n** and **180p**, is carried principally by electrons in the n-type layer **120n** and by electron vacancies or "holes" in a p-type layer **120p**. The electrons and holes move in opposite directions toward the active region **140** or a junction, where they recombine with one another. Energy released by the electron-hole recombination is emitted from the LED as light. As used herein, the term "light" includes visible light as well as electromagnetic radiation in the infrared and ultraviolet wavelength ranges. The wavelength of the emitted light depends upon many factors, including the composition of the semiconductor materials, the structure of the junction, the presence or absence of impurities or doping, and the like.

[0033] Suitably, the LED is mounted to the support **200** in flipped orientation, that is, with the light-generating region **140** proximate to the support **200** and the substrate **160** distal from the support **200**. FIGURES 5, 6 and 7 show exemplary contact layouts or contact traces for flip-chip bonding. Bump areas are designated for each electrode or contact type. For example, n-type bump areas **320n** are

designated on the n-type contact **180n** or n-type trace, and p-type bump areas **320p** are designated on the p-type contact **180p** or p-type trace. The respective bump areas correspond to the locations, within the respective p and n-type contact layouts or traces, where the bumps **300** contact and/or bond with the respective p and n-type electrodes or contacts **180p** and **180n**.

[0034] Suitably, the die **100** is mounted to the support **200** with a TS bonding process. One or more other suitable bonding processes, however, may alternately or additionally be employed, e.g., a thermocompression process, a soldering process, etc. The contacts **180n** and **180p** are suitably formed from one or more layers, e.g., that create a suitable electrically (and optionally thermally) conductive bond with the support **200**. Optionally, at the support-facing end, the contacts **180n** and **180p** have a metallization or metallization layer that includes one or more layers of metal, metal alloys, or the like. Suitably, for TS bonding, the terminating surfaces where the bump areas **320n** and **320p** are designated, include an Au surface or layer. Similarly, the bumps **300** are also formed from one or more layers, e.g., that create a suitable electrically (and optionally thermally) conductive bond between the contacts **180n** and **180p** and the support **200**. For TS bonding, the bumps **300** are suitably formed from Au or include an outer coating or layer of Au. Alternately, for a soldering process, the bumps **300** are formed from solder.

[0035] Suitably, the epitaxial structure **120** and contacts **180n** and **180p** are successively produced in layers upon the substrate **160**, one over the other, to form the die **100**, e.g., via epitaxial deposition or other suitable layering/coating or growth processes. For example, these may include metal-organic chemical vapor deposition (MOCVD; also known in the art as organometallic vapor phase epitaxy, OMVPE, and similar nomenclatures), molecular beam epitaxy (MBE), liquid phase epitaxy (LPE), or another suitable epitaxial growth technique or metallization process. As with the choice of substrate material, the choice of growth or layering technique is made based on the type of layer being produced.

[0036] In a suitable embodiment, after mesa formation, the p-type metal is deposited on the p-type contact layer (suitably, a GaN layer). The n-type contact is then defined and the device is protected, e.g., with a dielectric, along with definition of the p and n-type bump areas. The device is annealed at 250° C. After separation,

the individual die **100** is ready for flip-chip bonding and subsequently thermosonically bonded to the support **100**, with Au-terminated bumps **300**.

[0037] In a suitable embodiment, the bumps **300** are formed and/or arranged on the support **200** so as to enable the chip or die **100** to be attached or bonded to the support **200** via the corresponding p and n-type bump areas **320p** and **320n**. The bonding of the die **100** to the support **200** is suitably achieved via a TS bonding process, e.g., with the application of ultrasonic energy, and suitably without any intermediate melting/re-solidification step. Consequently, lower packaging temperatures (e.g., around approximately 150° C) can be used, thus avoiding loss of reflectivity of the p-type contact **180p**. In addition, the use of Au bumps **300** instead of solder, lowers the thermal resistance of the package.

[0038] Deformation of the bumps **300**, and physical bonding of the bumps **300** to the respective p and n-type bump areas **320p** and **320n** designated on the chip **100**, occurs in the TS bonding process. Suitably, therefore, if TS bonding is being employed, the die **100** is formed so that the p and n-type bump areas **320p** and **320n** on the chip **100** are at substantially similar elevations, i.e., within the extent of deformation of the bumps **300**. As best seen in FIGURE 5, the LED die **100** for use in the TS bonding application has a thickened or elevated n-type contact **180n**.

[0039] In accordance with aspects of the present inventive subject matter, a number of general features and several exemplary contact layouts or traces embodying the same are proposed which provide: optimized current spreading with minimal loss of light extraction efficiency; and, advantageous mounting performance or characteristics for TS bonding of dies or chips to their supports, e.g., in the flip-chip configuration. As seen in FIGURES 5, 6, 7 and 8, one feature entails elimination of the n-type trace on the outside or outer periphery of the chip, while still maintaining adequate current spreading with an n-type trace network in the interior of the chip. This design feature also results in the n-type bump areas being surrounded by p-type bump areas, thus, reducing problems associated with variations of the p and n-type bump heights on the support; in effect, it is more mechanically robust, e.g., in comparison to some of the designs discussed in the above-background. Suitably, as best seen in FIGURES 6, 7 and 8, the n-type trace defines an open ended path, as opposed to a closed path or loop, such as the one shown in FIGURE

2. Referring again the examples shown in FIGURES 6, 7 and 8, the n-type trace optionally follows an elongated sinuous path through the chip's interior, thereby providing a suitably extensive neighboring boundary with the proximate p-type trace that is well distributed throughout the chip. This advantageously promotes uniform current spreading. In contrast, the n-type trace of FIGURE 4 has a significantly less extensive neighboring boundary with the proximate p-type trace, and is more localized with respect to the entire chip.

[0040] Optionally, the current spreading is further enhanced, by having an n-type GaN layer with low resistivity (e.g., less than approximately 20 ohms/square). Additional advantage is achieved by connecting all the n-type trace portions together in a continuous network, thereby avoiding problems associated with an imperfect connection to, or bonding of, any one portion of the n-type trace. Robustness is further enhanced by yet another feature, namely, the p and n-type bump areas being at approximately the same level or elevation (see, e.g., FIGURE 5). Assuming the difference between these surface levels or elevations is within the deformation range of the bumps, a reliable connection across the chip is achieved reproducibly.

[0041] Notably, dies with designs shown in FIGURES 6, 7 and 8 have been attached to sub-mounts with Au-terminated bumps and shown to have excellent mechanical robustness, e.g., when compared to some of the designs discussed in the above-background. In addition, substantially the entire p-type mesa lights up under forward bias, indicating uniform light emission, good current spreading and good contact at both the p and n-type regions of the chip with the sub-mount. These designs have also been demonstrated to result in a low thermal resistance at the chip/sub-mount interface.

[0042] In connection with the particular exemplary embodiments presented herein, certain structural and/or function features are described as being incorporated in particular embodiments. It is to be appreciated that different aspects of the exemplary embodiments may be selectively employed as appropriate to achieve other alternate embodiments suited for desired applications, the other alternate embodiments thereby realizing the respective advantages of the aspects incorporated therein.

[0043] Additionally, it is to be appreciated that certain elements described herein as incorporated together may under suitable circumstances be stand-alone elements or otherwise divided. Similarly, a plurality of particular functions described as being carried out by one particular element may be carried out by a plurality of distinct elements acting independently to carry out individual functions, or certain individual functions may be split-up and carried out by a plurality of distinct elements acting in concert. Alternately, some elements or components otherwise described and/or shown herein as distinct from one another may be physically or functionally combined where appropriate.

[0044] In short, the present specification has been set forth with reference to exemplary embodiments. Obviously, modifications and alterations will occur to others upon reading and understanding the present specification. It is intended that the inventive subject matter be construed as including all such modifications and alterations insofar as they come within the scope of the appended claims or the equivalents thereof.

[0045] WHAT IS CLAIMED IS: